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Attorney Docket No. 108298715US  
Disclosure No. 03-0117.00/US

PTO/SB/08a/b (08-03)

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Substitute for form 1449A/B/PTO				<b>Complete if Known</b>	
				Application Number	10/646,673-Conf. #1020
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)				Filing Date	August 21, 2003
				First Named Inventor	Kevin L. Beaman
				Art Unit	1762
				Examiner Name	T. H. Meeks
				Attorney Docket Number	108298715US
Sheet	1	of	13		

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
JS		US-09/651,037	Filed 08-30-2000	Mardian	
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Examiner Signature		Date Considered	4/19/05
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Attorney Docket No. 108298715US  
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
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				Art Unit	1762
				Examiner Name	T. H. Meeks
Sheet	2	of	13	Attorney Docket Number	108298715US

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				Examiner Name	T. H. Meeks
Sheet	3	of	13	Attorney Docket Number	108298715US

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	US-2004/0083961-A1	05-06-2004	Basceri	

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				Examiner Name	T. H. Meeks
Sheet	4	of	13	Attorney Docket Number	108298715US

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	US-2004/0154538-A1	08-12-2004	Carpenter et al.	
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Examiner Signature		Date Considered	4/19/05
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Sheet	5	of	13	Attorney Docket Number	108298715US

<input checked="" type="checkbox"/>	US-5,131,752	07-21-1992	Yu et al.	
<input checked="" type="checkbox"/>	US-5,136,975	08-11-1992	Bartholomew et al.	
<input checked="" type="checkbox"/>	US-5,172,849	12-22-1992	Barten et al.	
<input checked="" type="checkbox"/>	US-5,200,023	04-06-1993	Gifford et al.	
<input checked="" type="checkbox"/>	US-5,223,113	06-29-1993	Kaneko et al.	
<input checked="" type="checkbox"/>	US-5,232,749	08-03-1993	Gilton	
<input checked="" type="checkbox"/>	US-5,248,527	09-28-1993	Uchida et al.	
<input checked="" type="checkbox"/>	US-5,364,219	11-15-1994	Takahashi et al.	
<input checked="" type="checkbox"/>	US-5,377,429	01-03-1995	Sandhu et al.	
<input checked="" type="checkbox"/>	US-5,380,396	01-10-1995	Shikida et al.	
<input checked="" type="checkbox"/>	US-5,409,129	04-25-1995	Tsukada et al.	
<input checked="" type="checkbox"/>	US-5,418,180	05-23-1995	Brown	
<input checked="" type="checkbox"/>	US-5,427,666	06-27-1995	Mueller et al.	
<input checked="" type="checkbox"/>	US-5,433,835	07-18-1995	Demaray et al.	
<input checked="" type="checkbox"/>	US-5,445,491	08-29-1995	Nakagawa et al.	
<input checked="" type="checkbox"/>	US-5,480,818	01-02-1996	Matsumoto et al.	
<input checked="" type="checkbox"/>	US-5,498,292	03-12-1996	Ozaki	
<input checked="" type="checkbox"/>	US-5,500,256	03-19-1996	Watabe	
<input checked="" type="checkbox"/>	US-5,522,934	06-04-1996	Suzuki et al.	
<input checked="" type="checkbox"/>	US-5,536,317	07-16-1996	Crain et al.	
<input checked="" type="checkbox"/>	US-5,562,800	10-08-1996	Kawamura	
<input checked="" type="checkbox"/>	US-5,589,002	12-31-1996	Su	
<input checked="" type="checkbox"/>	US-5,592,581	01-07-1997	Okase	
<input checked="" type="checkbox"/>	US-5,595,606	01-21-1997	Fujikawa et al.	
<input checked="" type="checkbox"/>	US-5,599,513	02-04-1997	Masaki et al.	
<input checked="" type="checkbox"/>	US-5,624,498	04-29-1997	Lee et al.	
<input checked="" type="checkbox"/>	US-5,626,936	05-06-1997	Alderman	
<input checked="" type="checkbox"/>	US-5,640,751	06-24-1997	Faria	
<input checked="" type="checkbox"/>	US-5,643,394	07-01-1997	Maydan et al.	
<input checked="" type="checkbox"/>	US-5,654,589	08-05-1997	Huang et al.	
<input checked="" type="checkbox"/>	US-5,693,288	12-02-1997	Nakamura	
<input checked="" type="checkbox"/>	US-5,729,896	03-24-1998	Dalai et al.	



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Sheet	6	of	13	Attorney Docket Number	108298715US

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Sheet	7	of	13	Attorney Docket Number	108298715US

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	US-6,237,529	05-29-2001	Spahn	

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--------------------	---	-----------------	---------

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Sheet	8	of	13	Attorney Docket Number	108298715US

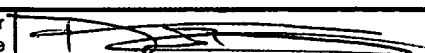
38	US-6,245,192	06-12-2001	Dhindsa et al.	
	US-6,255,222	07-03-2001	Xia et al.	
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38	US-6,432,259	08-13-2002	Noorbaksh et al.	

Examiner Signature		Date Considered	4/19/05
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				Examiner Name	T. H. Meeks
Sheet	9	of	13	Attorney Docket Number	108298715US

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<input type="checkbox"/>	US-6,562,141	05-13-2003	Clarke	
<input type="checkbox"/>	US-6,573,184	06-03-2003	Park	
<input type="checkbox"/>	US-6,579,372	06-17-2003	Park	
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<input type="checkbox"/>	US-6,673,196	01-06-2004	Oyabu	
<input type="checkbox"/>	US-6,704,913	03-09-2004	Rossman	
<input type="checkbox"/>	US-6,705,345	03-16-2004	Bifano	
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<input checked="" type="checkbox"/>	US-6,818,249-B2	11-16-2004	Derderian	

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PTO/SB/08a/b (08-03)

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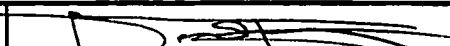
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				Application Number	10/646,673-Conf. #1020
				Filing Date	August 21, 2003
				First Named Inventor	Kevin L. Beaman
				Art Unit	1762
				Examiner Name	T. H. Meeks
Sheet	10	of	13	Attorney Docket Number	108298715US

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				Art Unit	1762
				Examiner Name	T. H. Meeks
Sheet	11	of	13	Attorney Docket Number	108298715US



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<input type="checkbox"/>	SU-598630	03-25-1978	Veremeichuk		
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<input type="checkbox"/>	WO-02/073329-A2	09-19-2002	Applied Materials, Inc.		
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<input type="checkbox"/>	WO-01/46490-A1	06-28-2001	Lam Research Corporation		
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<input type="checkbox"/>	WO-02/081771-A2	10-17-2002	Angstrom Systems, Inc.		
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<input checked="" type="checkbox"/>	JP-2001-254181-A	09-18-2002	Tokyo Electron Ltd.		✓


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